AIDAINNOVA

Additive Manufacturing by LPBF technology

WP10 26.04.2023

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CSEM aim for AIDAINNOVA WP10

• AM metal

 Define the optimal geometrical features attainable for 3D printed ultra-thin cold plates in metal alloys

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CSEM objectives for AIDAINNOVA WP10

- AM of metal alloys → AlSi12 (stiffness to weight ratio and high thermal conductivity)
- Quality evaluation of built parts
 - Thermal conductivity
 - Long test cavity (single pipes & multi-channel)
 - Inner wall roughness (single pipes & multi-microchannel)
 - Dimensional accuracy
 - Flatness (multi-microchannel)
- Minimal wall thickness
 - Minimum leak-tight wall thickness (single pipes & multi-microchannel)

- Powder management
 - Minimum ratio (D/L) for single pipes (straight & 180 degree-bent geometry)
 - Minimum ratio (D/L) for multi-microchannel



CSEM objectives for AIDAINNOVA WP10

• AM of metal alloys → COVAR & INVAR (low CTE)

• Phase 1

- Benchmarking for AM grade powder
- Development of process parameters
- Best candidate (COVAR or INVAR) selection based on obtained results

• Phase 2

• Same investigation as AlSi12 but on a limited number of configuration

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Technical Achievements

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- Minimal wall thickness strategy
 - AlSi12

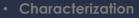
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• Laser power tune in single track laser

• Thickness tuned by CADs

Power tuning

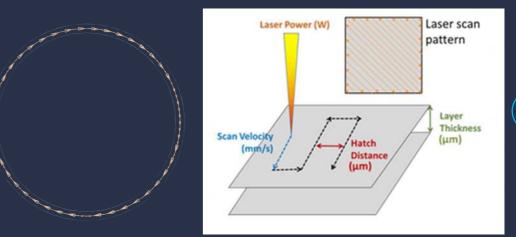
• Laser power tune in double track laser



- Thermal conductivity
- Long test cavity (single pipes & multi-channe
- Inner wall roughness (single pipes & multi-microchannel)
- Dimensional accuracy
- Flatness (multi-microchannel

Minimal wall thickness

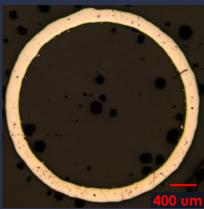
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- Powder management
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- Minimum ratio (D/L) for multi-microchanne



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Fine tuning

• Tuning between 100 W and 110 W



- Minimal wall thickness strategy
 - AlSi12 → 1) Laser power tune on single-line (SL) X



- Minimal wall thickness strategy
 AlSi12
 - Laser power tune in single track laser

• Thickness tuned by CADs

Power tuning

Laser power tune in double track laser

Fine tuning

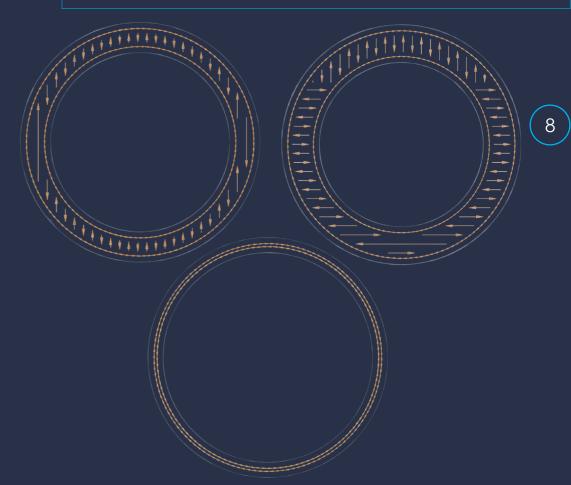
Tuning between 100 W and 110 W

Characterization

- Thermal conductivity
- Long test cavity (single pipes & multi-channel
- Inner wall roughness (single pipes & multi-microchannel
- Dimensional accuracy
- Flatness (multi-microchannel

Minimal wall thickness

- Minimum leak-tight wall thickness (single pipes & multi-microchannel)
- Powder management
- Minimum ratio (D/L) for single pipes (straight & 180 degree-bent geometry)
- Minimum ratio (D/L) for multi-microchanne





- Minimal wall thickness strategy
 - AlSi12 -> 2) Thickness tuned by CAD •

CAD thickness tuning

- 550 (um) Method: Results by tuning the design thickness • on lead high pressure leak-tight parts Results: Except some defects parts, • 250 all printed parts are leaktight
 - Wall thickn 150 150 250 350 450

Wall thickness CAD (um)

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550



- Minimal wall thickness strategy
 - AlSi12 → 2) Thickness tuned by CAD

CAD thickness tuning



Wall thickness CAD (um)

10)



- Minimal wall thickness strategy
 - AlSi12





Power tuning

• Laser power tune in double track laser

Fine tuning

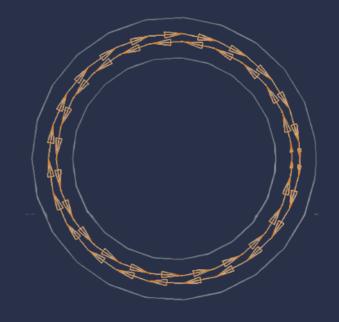
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Characterization

- Thermal conductivity
- Long test cavity (single pipes & multi-channe
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Minimal wall thickness

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- Minimal wall thickness strategy
 - AlSi12 \rightarrow 3) Laser power tuning on double-line (DL)



■ 1/8 pipe

- Method:
 - Change laser power on an optimized recipe always keeping two laser tracks
- Results:
 - \geq 110 W \rightarrow Leak-tight (180 um)
 - < 110 W \rightarrow Not leak-tight (170 um)

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- Minimal wall thickness strategy
 - AlSi12



Thickness tuned by CADs

Power tuning

Laser power tune in double track laser

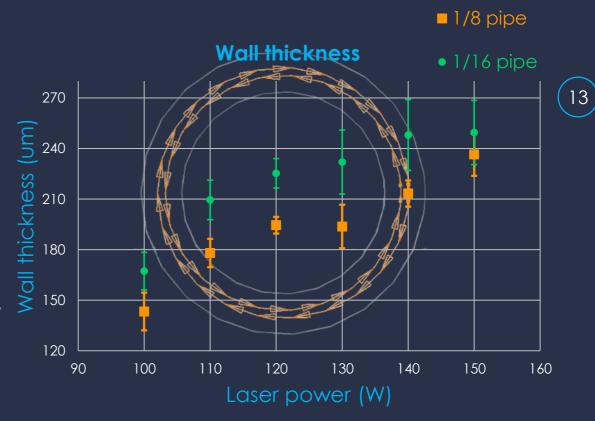
Fine tuning

• Tuning between 100 W and 110 W

Thermal conductivity Long test cavity (single pipes & multi-channel) Inner wall roughness (single pipes & multi-microchannel) Dimensional accuracy Flatness (multi-microchannel) Minimal wall thickness Minimum leak-tight wall thickness (single pipes & multi-microchannel) Powder management

Characterization

Minimum ratio (D/L) for multi-microchannel



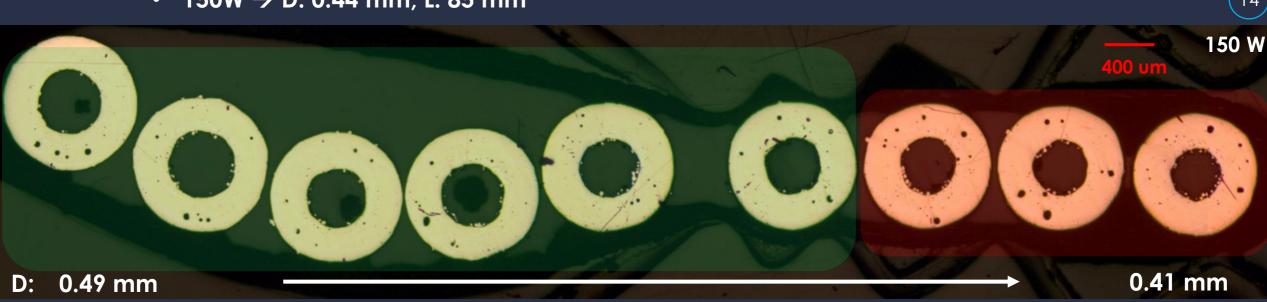
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- Powder management
 - AlSi12 \rightarrow straight pipe
 - Minimum hole diameter to length ratio for single straight pipe
 - Method:
 - Print maximal length possible (85 mm) & change hole size.
 - Results:

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• 150W → D: 0.44 mm, L: 85 mm

- Characterization
- Thermal conductivity
- Long test cavity (single pipes & multi-channe
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- Flatness (multi-microchannel)
- Minimal wall thickness
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Explorative part

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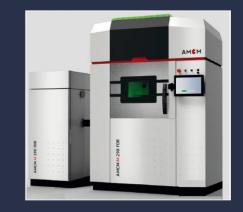
• AlSi12

- Pulsed laser
- HIP post-process
- Boost the process limit of AM
- Diamond composite



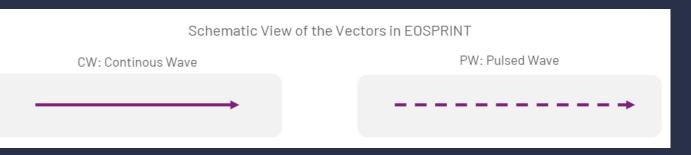


• AlSi12 \rightarrow Pulsed laser

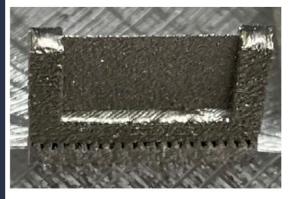


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Better control of introduced heat compared to a continuous wave



Build Part of a Thin Wall:



Pulsed Laser Operation Thin Walls with In718 (40µm)

Thin Walls

- Single line exposure with Pulsed Laser Feature
- Wall thickness around 120µm
- Vertical wall: gas tight to air pressure of 2 bar

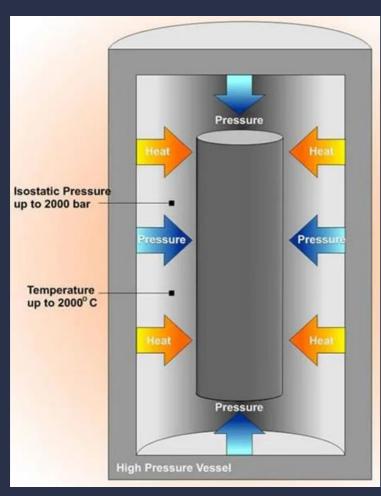
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- Pulsed laser
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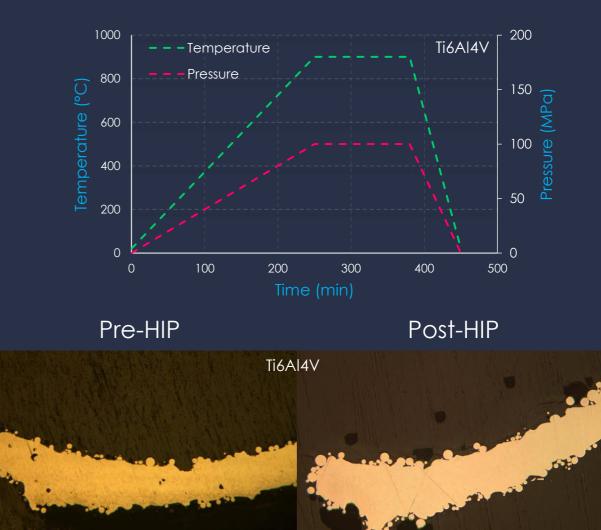


AlSi12 → HIP post-process



Schematic of the Hot Isostatic Pressing Process *Azo material

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Porosity decreasing

• AlSi12

- Pulsed laser
- HIP post-process
- Boost the process limit of AM
- Diamond composite



• AlSi12 \rightarrow Boost the process limit of AM

- Different roughness in the same part (fluid dynamics)
- Internal pipe structurization (induce phase transition)
- Exploit design freedom internal porous pipe and external tight pipe (improve phase transition)

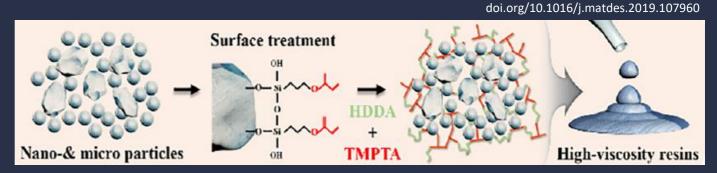


• AlSi12

- Pulsed laser
- HIP post-process
- Boost the process limit of AM
- Diamond composite printing



• AlSi12 \rightarrow diamond composite (C – SiC)



- High features definition
- Low CTE (?)
- Th. cond. ~400 W/(m * K)
- High MP (?)



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Conclusion

- A first investigation to find the minimal wall thickness was successful. Further development can be achieved by pulsed laser, which allows better control of the wall thickness, as well as HIP post-processing.
- Minimal hole diameter is more challenging to establish for LPBF process as it depends on materials (flowability, particles size) and final proprieties (roughness). For AlSi12, a D/L ratio of 0.44/85 is found. Reproducibility still needs to be investigated.

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• Perspectives on new technological approaches, such as structured pipes and diamond printing, need to be analysed.

